

10/088964

JC13 Rec'd PCT/PTO 22 MAR 2002

SADH

PATENT APPLICATION

#2

9.18.02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akihiro GOTO, et al.

PCT/JP99/06630

Appln. No. ~~Not yet assigned~~

10/088964

4903

Confirmation No. ~~Not yet assigned~~

Group Art Unit: ~~Not yet assigned~~

1741

Filed: March 22, 2002

Examiner: ~~Not yet assigned~~

Mayo Kan

For: A METHOD OF MANUFACTURING AN ELECTRODE FOR DISCHARGE SURFACE TREATMENT

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.97 and 1.98

Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to Applicants' duty of voluntary disclosure under Rule 56, and for the Examiner's convenience, we submit herewith:

- a) a form PTO-1449 listing seven (7) (references of potential relevancy); and,
- b) a complete copy of each reference.

No certification or fee is required.

Regarding the concise explanation of relevancy requirement for foreign language documents, an English-language Abstract or partial translation is attached for each foreign language document not cited in the ISR.

Respectfully submitted,

SUGHRUE MION, PLLC
2100 Pennsylvania Avenue, N.W.
Washington, D.C. 20037-3213
Telephone: (202) 293-7060
Facsimile: (202) 293-7860



Richard C. Turner
Registration No. 29,710

Date: March 22, 2002

PRIOR ART INFORMATION LIST

FOR SUBMITTING IDS

Your Ref :	
MITSUBISHI Ref :	519185-US-02
Our Ref :	PMDA-01114-US

Country, Application /Publication/Patent Number, Author, Title, Name of Document	Issue date	Concise Explanation of the Relevance (indication of page, column, line, figure of the relevant portion)
	(Application Date)	
* ① Japan No. HEI 9-192937 A	Jul. '19, 1997	* Cited refernce of THE INTERNARIONAL SEARCH REPORT.
② Japan No. HEI10-130318	(May 13, 1998)	English Abstract
③ "Formation of Hard Layer on Metalic Material EDM", A. Goto et al., VDI BERICHTE 1405	1998	
* ④ Japan No. HEI 5-148615 A	Jun. 15, 1993	English Abstract

* : The prior art document identified in the specification.